

Journal of
Vacuum Science
& Technology A

JVST A

An International Journal devoted to
Vacuum, Surfaces,
and Films



Editor

G. Lucovsky, *North Carolina
State University*

ISI's Impact and Immediacy Data (2006)

Impact Factor: 1.394

Immediacy Index: 0.199



Journal of Vacuum Science & Technology A: Vacuum, Surfaces and Films

<http://scitation.aip.org/jvsta/>

JVST A & B publish over 6,000 pages annually—now available on CD-ROM and online

An official publication of the AVS, the journal publishes reports of original research, Review Articles and clusters of papers, and the conference papers from the Annual AVS conference. *JVST A & B* are also available on CD-ROM, in regular quarterly distribution, and are available online. *JVST A & B* are primary information resources for engineers, physicists, chemists, materials scientists, microelectronics specialists, and technicians working in all areas of vacuum science, surfaces, microelectronics, and thin film materials science.

2008 Publication Frequency

Volume 26 (6 issues)

Format

Print, online, CD-ROM

Online Backfile

1964-2007

ISSN 0734-2101

CODEN JVTAD6

Journal of
Vacuum Science
& Technology B

JVST B

An International Journal devoted to
Microelectronics and
Nanometer Structures
Processing, Measurement,
and Phenomena

Edited by
Gary E. McGuire



Editor

Gary E. McGuire, *International
Technology Center, Research
Triangle Park, NC*

ISI's Impact and Immediacy Data (2006)

Impact Factor: 1.597

Immediacy Index: 0.268

Journal of Vacuum Science & Technology B: Microelectronics and Nanometer Structures

<http://scitation.aip.org/jvstb/>

JVST A & B publish over 6,000 pages annually—now available on CD-ROM and online

By emphasizing microelectronics and nanometer science, *JVST B* is the major journal for electronic materials and device processing, for nanometer scale physics and engineering, and also as a source for papers from major international conferences. Papers will be published from the Annual Physics and Chemistry of Semiconductor Interfaces Conference, the International Electron, Ion, and Photon Beam Technology and Nanofabrication Conference, and the International Vacuum Microelectronics Conference. *JVST A & B* are also available on CD-ROM in regular quarterly distribution, and are available online.

2008 Publication Frequency

Volume 26 (6 issues)

Format

Print, online, CD-ROM

Online Backfile

1964-2007

ISSN 1071-1023

CODEN JVTBD9